



EV372461036

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/071,425
Filing Date February 8, 2002
Confirmation No. 1727
Inventor Terry L. Gilton
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Thanhha S. Pham
Attorney's Docket No. MI22-1828
Customer No. 021567
Title: Semiconductor Processing Method Using Photoresist and an Antireflective
Coating

RESPONSE AFTER JUNE 29, 2004 NOTICE OF ALLOWANCE
PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop RCE
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

VIA EXPRESS MAIL

From: Mark S. Matkin (Tel. 509-624-4276; Fax 509-838-3424)
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Responsive to the Notice of Allowance dated June 29, 2004, Applicant
remarks as follows:

AMENDMENTS